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INFORMATION DISCLOSURE
STATEMENT BY APPLICANT

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| Application Number | 09/887,767 |
| Confirmation Number | 9072 |
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| First Named Inventor | Whonchee Lee |
| Group Art Unit | 3723 |
| Examiner Name | |

Substitute for form 1449A/PTO

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108298515US2

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EXAMINER

Alvin D. Grant

DATE CONSIDERED

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